

2825

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SERIAL NO.: 09/975,840

GROUP: 2825

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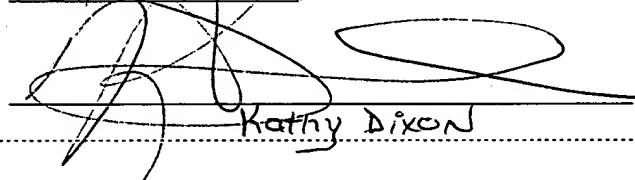
TITLED: METHODS AND SYSTEMS FOR FORMING EMBEDDED DRAM
FOR AN MIM CAPACITOR

CERTIFICATE OF FACSIMILE

Please forward all correspondence to:

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RESPONSE TO OFFICE ACTION

Dear Sir:

In response to the Office Action mailed January 27, 2004, please enter the following
amendments and consider the following remarks.